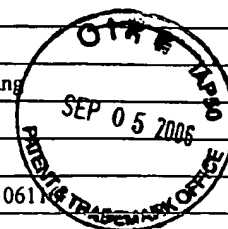


INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Multiple sheets used when necessary)</i>	Application No.	10/807,147
	Filing Date	March 24, 2004
	First Named Inventor	Tsai, Hsiung-Kuang
	Art Unit	2873
SHEET 1 OF 3	Examiner	Lester, E.
	Attorney Docket No.	QCO.090A/IDC- 061



U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	1	4,074,480	02-21-1978	Burton	
	2	4,956,619	09-11-1990	Hornbeck	
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Examiner Signature	/Evelyn Lester/	Date Considered	12/29/2006
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>			

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	Filing Date	March 24, 2004
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	Art Unit	2873
SHEET 2 OF 3		Examiner Lester, E.
		Attorney Docket No. QCO.090A/IDC- 06116

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	30	2003-0075794	04-24-2003	Felton, et al.	
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
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Examiner Signature	/Evelyn Lester/	Date Considered	12/29/2006
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(Multiple sheets used when necessary)	Examiner	Lester, E.
SHEET 3 OF 3	Attorney Docket No.	QCO.090A/IDC- 06116

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
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